

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT  
(Under 37 CFR 1.17(p) or 1.97(c))**

Docket No.  
**BUR920040122US1**

In Re Application Of: **June Cline et al.**

*OCT 29 2004*

*PATENT & TRADEMARK EXAMINER*

Application No.	Filing Date	Customer No.	Group Art Unit	Confirmation No.
<b>10/711,953</b>	<b>10-15-2004</b>	<b>30449</b>		

**Title: DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION**

Address to:

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

**37 CFR 1.97(b)**

- The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

**37 CFR 1.97(c)**

- The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

the statement specified in 37 CFR 1.97(e);

**OR**

the fee set forth in 37 CFR 1.17(p).

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 (Under 37 CFR 1.97(b) or 1.97(c))

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**Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

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3 Lear Jet Lane, Suite 201

Latham, NY 12110

(518) 220-1850

CC:

<b>O I P INFORMATION DISCLOSURE CITATION</b> <small>(Use several sheets if necessary)</small>			ATTY DOCKET NO. <b>BUR920040122US1</b>	APPLICATION NO. <b>10/711,953</b>		
<small>OCT 29 2004</small>			APPLICANT(S) <b>June Cline et al.</b>			
			FILING DATE <b>10-15-2004</b>	GROUP ART UNIT		
<b>U.S. PATENT DOCUMENTS</b>						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
						NO
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>						
			<b>HANDBOOK OF THIN FILM TECHNOLOGY, Edited by Leon I. Maissel and Reinhard Glang, Copyright: 1970, p. 7-44.</b>			
EXAMINER			DATE CONSIDERED			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>						